



**ELECTRONIC COPY**

LG800667600  
Report verification at [igi.org](http://igi.org)



May 12, 2026  
IGI Report Number **LG800667600**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **14.10 X 9.96 X 6.53 MM**  
**GRADING RESULTS**  
Carat Weight **8.01 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

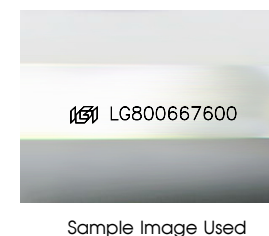
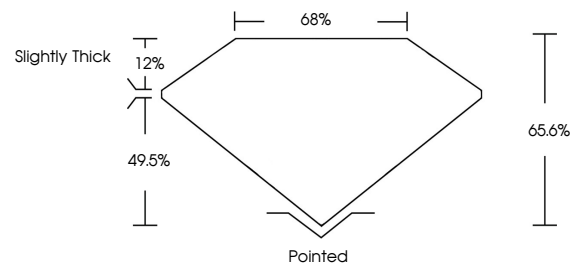
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**ADDITIONAL GRADING INFORMATION**

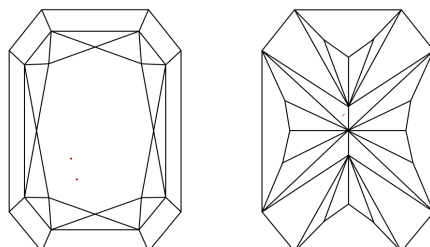
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG800667600**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

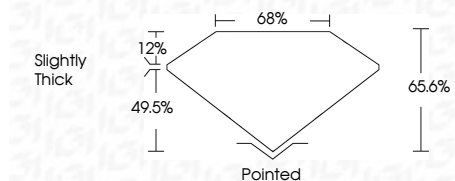
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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CUT CORNERED RECT. MODIFIED BRILLIANT  
14.10 X 9.96 X 6.53 MM  
8.01 CARATS  
E  
VVS 2  
65.6%  
49.5%  
Slightly Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG800667600  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa